Lawrence Berkeley National Laboratory

Recent Work

Title SILVER PLATING ON INCONEL

Permalink https://escholarship.org/uc/item/24r8f8vc

Author Cook, Leslie J.

Publication Date 1950-12-28



cobils UCRL

UNCLASSIFIED

TWO-WEEK LOAN COPY

This is a Library Circulating Copy which may be borrowed for two weeks. For a personal retention copy, call Tech. Info. Division, Ext. 5545

RADIATION LABORATORY

DISCLAIMER

This document was prepared as an account of work sponsored by the United States Government. While this document is believed to contain correct information, neither the United States Government nor any agency thereof, nor the Regents of the University of California, nor any of their employees, makes any warranty, express or implied, or assumes any legal responsibility for the accuracy, completeness, or usefulness of any information, apparatus, product, or process disclosed, or represents that its use would not infringe privately owned rights. Reference herein to any specific commercial product, process, or service by its trade name, trademark, manufacturer, or otherwise, does not necessarily constitute or imply its endorsement, recommendation, or favoring by the United States Government or any agency thereof, or the Regents of the University of California. The views and opinions of authors expressed herein do not necessarily state or reflect those of the United States Government or any agency thereof or the Regents of the University of California.

Copy 2

UCRL-1068 Unclassified-Physics Distribution

UNIVERSITY OF CALIFORNIA

Radiation Laboratory

Contract No. W-7405-eng-48

UNCLASSIFIED

SILVER PLATING ON INCONEL

Leslie J. Cook

December 28, 1950

Berkeley, California

UCRL-1068 Unclassified-Physics Distribution

SILVER PLATING ON INCONEL

-2-

Leslie J. Cook

Radiation Laboratory, Department of Physics University of California, Berkeley, California

December 28, 1950

Abstract

A method of electroplating silver onto Inconel is described. The deposits produced by this method have excellent adherence and are very fine grained. Films as thin as 0.0002 in. have been produced with an electrical conductivity of the order of 95 percent of the value for pure bulk silver.¹

Introduction

In the production of components for high frequency electrical equipment there are many applications for silver plating where it is essential that the surface have the highest possible electrical conductivity. This requirement is easily satisfied with plating thicknesses greater than about 0.001 in. on most common base metals. However, in all cases which have come to our attention, attempts to obtain high electrical conductivity in thinner films on such base metals as Inconel and stainless steel have been unsuccessful. In these earlier studies a number of rather unusual techniques were employed, including; preliminary buffing of the base metal, buffing of the finished plating, electrolytic passivation of the base metal, periodic reversals of the plating current, and the addition of various brightening agents to the plating bath. None of these techniques led to conductivities higher than about 55 percent.

The present investigation was concerned with the plating of silver, 0.0002 in. thick onto Inconel tubing, 3/8 in. in diameter. This tubing was then

¹ The electrical resistivity of pure silver, melted and annealed <u>in vacuo</u> is taken as 1.59×10^{-6} ohm-cm at 20° C. All relative conductivities given in the text are based on this value.

to be used as the center conductor of a coaxial cable and in order that the cable have the desired frequency characteristics it was necessary for the silver plating to have a conductivity of at least 90 percent. The technique described here has consistently produced conductivities of the order of 95 percent in films 0.0002 in. thick and employs only conventional electroplating techniques.

<u>The Process.</u> The operations are listed in the order in which they were performed. The whole process was carried out continuously. If the work was allowed to dry at any stage the quality of the finished plating was impaired.

<u>Preliminary Cleaning.</u> In the laboratory tests, satisfactory results were obtained by cleaning with soap and water or with organic solvents. In production, it was found more convenient to clean cathodically in a proprietary alkaline cleaner at 20 amperes per square foot for 1 minute. This was followed by rinsing in water. <u>Electrolytic Pickling.</u> The purpose of this step was to remove the passive chromium oxide and nickel oxide films, and to produce a surface structure fine in comparison with the thickness of the silver film to be plated. This is apparently the most critical step in the procedure, and it was controlled by observation of the pickled surface with a metallurgical microxcope at 500X. The pickling was done anodically in 10 percent hydrochloric acid. A typical treatment was 35 amperes per square foot for 3 minutes. The loosely adhering oxide was then conveniently removed by rubbing with a cotton cloth, followed by thorough rinsing in water.

The optimum current density and time varied over wide limits, depending on the condition of the alloy. A treatment which was too mild to strip the oxide on one batch of Inconel was so severe on another that it produced pits of the order of 0.005 in. in diameter. This effect is commonly observed in the demonstration of cold-work by electrolytic etching.

Nickel Strike. Adherence was promoted by plating at 75 amperes per square foot

-3-

for 10 minutes in a high chloride nickel strike bath. This was followed by a thorough rinse in water.

-4-

<u>Silver Strike</u>. The work was struck at 20 amperes per square foot for 30 seconds in a bath with the following composition:²

> AgCN 0.9 oz/gal KCN 10 oz/gal K_2CO_3 2 oz/gal

It was observed that in all cases where high-conductivity silver resulted, the strike was immediate and uniform, whereas in other cases it appeared more slowly and with some irregularity.

<u>Silver Plating</u>. The work was plated at 6 amperes per square foot for 10 minutes in a plating bath with the following composition:

an survey.	AgCN	4.8	oz/gal
	KCN	8.0	oz/gal
n in se Station	K2CO3	6.0	oz/gal

The silver strike bath and the silver plating bath were made up with C.P.grade chemicals and distilled water. It should be noted that no brightener was used. It was observed that when a brightener was used in a bath compounded with NaCN instead of KCN it did not really refine the grain, but merely produced a smoothing of the coarse grains.

Conductivity Measurement

The electrical conductivity of the deposit was determined by measuring conductonce the resistance of a 4-in. length of tubing before and after plating. Taking conductonce the difference as the resistance of the silver plate, the conductivity of the silver is calculated from the geometry of the film. The resistance of the tube

² The silver bath formulae are given by William Blum and George B. Hogaboom, "Principles of Electroplating and Electroforming", McGraw-Hill Book Company, Inc., New York.

was measured with a Kelvin double bridge. In order to determine the thickness of the deposit, plated specimens were mounted in bakelite moulding compound, prepared by the usual technique for finishing metallographic specimens, and measured with a microscope at 500X. The simpler technique of measuring the resistance of a stripped film was not applicable, because in order to strip the film it was necessary to passivate the surface of the base metal. The conductivity of such films was always less than 60 percent.

-5-

Acknowledgments

I should like to express my appreciation to Drs. Hugh Bradner and Herbert York of this laboratory for their interest and encouragement, and to Mr. Walter Gibbins and Mr. Richard Nickerson, who made many valuable contributions to this development in the laboratory stage. I am indebted to Mr. Rees Makins and the staff of the M-W Laboratories in Chicago, Ill., and to the engineering staff of the Andrew Corp. of Chicago, Ill., for their generous cooperation during the production stage of the development. This work was supported by the Atomic Energy Commission.

Information Division 1/5/51 cg